PATENT	NUM	3ER	and
ISS	UE DA	TE	

U.S. UTILITY Patent Application

APPL NUM	FILING DATE	CLASS	SUBCLASS	GAU		EXAMINER	
10015757	12/17/2001	257		2811	PI	N'S	
"APPLICANTS	: Kim Hyı	ing-Jun;				Company of the Compan	
*CONTINUING	DATA VERIFIED):					
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FOREIGEN AD	PLICATIONS VE	DICIED.					
	OREA 2000-808		/2000				
		O. 12/22/	2000				
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G-PUB DO NO	T PUBLISH 🖵		RESCIN				
ereign priority claims 5 USC 119 condition		□ yes □ yes		•	АТТО	RNEY DOCKET NO	
eriiied and Acknowle	edged Examiners's in	tials			P6735		
TLE: : Semicono echanical polish	ductor device cap	able of p	reventing corre	osion of	metal wi	res from CMP (che:	nical
onamour poisi	mg/ process				U.S.DEF	T. OF COMM./PAT.& TM-PTO-43	5L(Rev 12-9
							

NOTICE OF ALL	OWANCE MAILED		CLAIMS ALLOWED				
ISSUE FEE		Assistant Examiner	Total Claims		Print Claim for O.G		
		1	DRAWING				
Amount Due Date Paid	7	Sheets Drwg.	Figs.Drwg.	Print Fig.			
		Primary Examiner		<u> </u>			
TERMINAL		PREPARED FOR ISSUE	Applicati n Examiner				
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